

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: KAJIHARA, et al.  
Serial No.: 09/328,910  
Filed: June 9, 1999  
For: LEADFRAME SEMICONDUCTOR INTEGRATED  
CIRCUIT DEVICE USING THE SAME, AND METHOD  
OF AND PROCESS FOR FABRICATING THE TWO  
Group: 2815  
Examiner: J. Clark  
Conf. No.: 7455

**STATEMENT OF SUBSTANCE OF INTERVIEW**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

February 14, 2008

Sir:

The following statement of the substance of the personal interview conducted between the PTO personnel as listed on the Interview Summary and the undersigned on January 8, 2008 is being submitted in reply to the requirement in the Interview Summary dated January 15, 2008.

The statement of the substance of the interview in the Interview Summary is complete and correct.

To the extent necessary, applicants petition for an extension of time under 37 CFR 1.136. Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli,

Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Case No.1374.32049R00),  
and please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

/Paul J. Skwierawski/  
Paul J. Skwierawski  
Registration No. 32,173

PJS/slk  
703-312-6600